

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

**Confirmation No.: 3619**

Tadashi MAEGAWA, et. al.

Date: November 10, 2006

Serial No.: 10/789,870

Group Art Unit: 1763

Filed: February 26, 2004

Examiner: Sylvia MaCARTHUR

For: SUBSTRATE PROCESSING APPARATUS

VIA EFS-WEB  
 Mail Stop AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

*Entered w/PCB*  
*12/29/06*  
*[Signature]*

**AMENDMENT/SUBMISSION**

Sir:

This is a response to the final Office Action mailed August 10, 2006 in the above-identified application. Reconsideration of the application is respectfully requested.

**FEE CALCULATION**

Any additional fee required has been calculated as follows:

☐ If checked, "Small Entity" status is claimed.

	NO. CLAIMS AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		EXTRA PRESENT		RATE	ADDIT. FEE
TOTAL	30	MINUS	30	* =	0	X	(\$25 SE or \$50)	\$0
INDEP.	6	MINUS	6	** =	0	X	(\$100 SE or \$200)	\$0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$180 SE or \$360)	\$0
* not less than 20      ** not less than 3								TOTAL \$ 0

If any additional payment is required, credit card payment in the amount of  
 \$ \_\_\_\_\_ is submitted via EFS-WEB.